

Application/Control No.	Applicant(s)/Patent under Reexamination
10/803,773	CAMACHO ET AL.
Examiner	Art Unit
John C. Hong	3726

SEARCHED					
Class	Subclass	Date	Examiner		
29	402.08,40 2.03,402.0 1,402.06	11/13/2005	A		
	402.09				
	402.11				
	402.12				
	402.14				
	426.1				
	426.4				
	428				
	505				
	525				
	525.01				
296	107.05				
	146.14				
	146.8				

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
29	402.08	11/13/2005	DW		
	402.01				

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